



**MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1775**

**PATENT
3313-1048P**

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: **CHEN, I-Cherng et al.** Conf.:6047

Appl. No.: **10/690,503** Group: **1775** *Do not enter*

Filed: **October 23, 2003** Examiner: **Cathy F.F. LAM** *CL. 05-25-05*

For: **MATERIAL WITH SURFACE NANOMETER FUNCTIONAL
STRUCTURE AND METHOD OF MANUFACTURING THE
SAME**

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313-1450

May 16, 2005

Sir:

In response to the Examiner's Office Action dated February 14, 2005, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes

Amendments to the Specification;

Amended Claim set; and

Remarks.